



INTERNATIONAL  
GEMOLOGICAL  
INSTITUTE

## ELECTRONIC COPY

### LABORATORY GROWN DIAMOND REPORT

December 8, 2025

IGI Report Number **LG750569841**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **ROUND BRILLIANT**

Measurements **8.09 - 8.16 X 4.92 MM**

#### GRADING RESULTS

Carat Weight **2.01 CARATS**

Color Grade **F**

Clarity Grade **VS 1**

Cut Grade **IDEAL**

#### ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**

Symmetry **EXCELLENT**

Fluorescence **NONE**

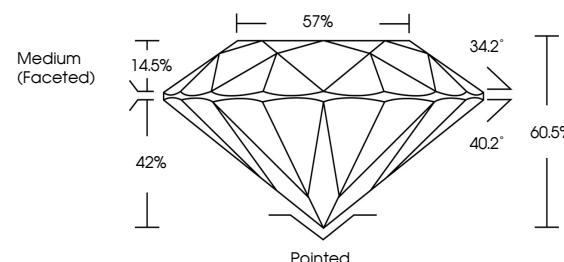
Inscription(s) **IGI LG750569841**

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.

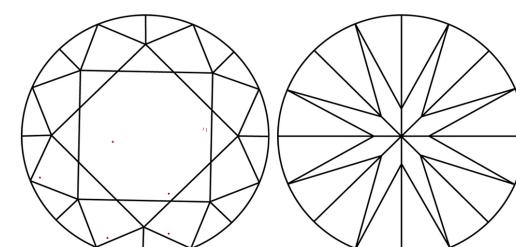
Type Ila

LG750569841  
Report verification at [igi.org](https://igi.org)

#### PROPORTIONS



#### CLARITY CHARACTERISTICS



#### KEY TO SYMBOLS

Red symbols indicate internal characteristics.

Green symbols indicate external characteristics.

LABORATORY GROWN DIAMOND REPORT



December 8, 2025

IGI Report Number **LG750569841**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **ROUND BRILLIANT**

Measurements **8.09 - 8.16 X 4.92 MM**

#### GRADING RESULTS

Carat Weight **2.01 CARATS**

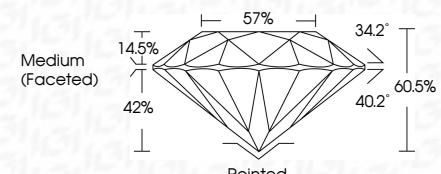
Color Grade **F**

Clarity Grade **VS 1**

Cut Grade **IDEAL**



Sample Image Used



#### ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**

Symmetry **EXCELLENT**

Fluorescence **NONE**

Inscription(s) **IGI LG750569841**

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.

Type Ila

[www.igi.org](https://igi.org)

© IGI 2020, International Gemological Institute



December 8, 2025

IGI Report No. LG750569841

ROUND BRILLIANT

8.09 - 8.16 X 4.92 MM

Carat Weight

Color Grade

Clarity Grade

Cut Grade

Depth

Table

Girdle

Medium (Faceted)

Pointed

Excellent

Excellent

Excellent

None

IGI LG750569841

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.

Type Ila

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.

Type Ila



**IGI**